

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE 2812

Applicant:

Xu et al.

Filed: May 10, 2001

Serial No. 09/854,177

For: METHOD AND SYSTEM FOR  
DETECTING METAL CONTAMINATION  
ON A SEMICONDUCTOR WAFER

Attorney Dkt. No. 5589-00501

I hereby certify that this correspondence is being transmitted  
via facsimile to USPTO, TC2800, 703/872-9318 on the date  
indicated below:April 26, 2002  
Date*Pamela Gerik*  
Pamela GerikPOWER OF ATTORNEY BY ASSIGNEE

Under the provisions of 37 C.F.R. § 3.71, the undersigned assignee of record of the entire interest in the above-identified patent/patent application by virtue of an assignment recorded (check as applicable):

☐ Concurrently herewith  
☐ Date Recorded  
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elects to conduct the prosecution of the application/maintenance of the patent to the exclusion of the inventor(s). The undersigned hereby declares that he has reviewed the above-referenced assignment and hereby declares that, to the best of his knowledge, title is in the Assignee, and further declares that all statements made herein of his own knowledge are true and that all statements made on information and belief are believed to be true. The assignee hereby revokes any previous powers of attorney and appoints the following to prosecute this application/maintain this patent and transact all business in the Patent and Trademark Office connected therewith:

Kevin McAndrews, Reg. No. 34,496 and Marius Domokos, Reg. No. 48,153 of KLA-Tencor, Inc.

Kevin L. Daffer, Reg. No. 34,146; B. Noel Kivlin, Reg. No. 33,929; and Eric B. Meyertons, Reg. No. 34,876 of Conley, Rose & Tayon LLP

Please direct all communications to: Conley, Rose & Tayon, P. O. Box 398, Austin, Texas 78767, Tel. No.: (512) 476-1400, to the attention of: Ann Marie Mewherter

ASSIGNEE  
KLA-TENCOR, INC.

Date:

4/22/02

BY:

*Stuart Nichols*Stuart Nichols  
Vice President and General Counsel